

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Hans Wilfried Peter KOOPS
Klaus EDINGER

Title: **PROCEDURE FOR ETTCHING OF MATERIALS AT THE SURFACE WITH FOCUSED ELECTRON BEAM INDUCED CHEMICAL REACTION AT SAID SURFACE**

Application Serial No. : 10/628,174

Filing Date: July 28, 2003

Assignee: NaWoTec GmbH

Confirmation No.: 5591

Priority claimed: October 16, 2002, European Patent No. 02 023 217.9

Examiner: Allan W. Olsen

Art Unit: 1763

Docket: 8183

Date: November 16, 2007

INTERVIEW SUMMARY RECORD

During the telephone interview on Tuesday November 13, 2007, the status of the application was discussed. The Examiner confirmed the previous Office Action from April 5, 2007 was incomplete and sent in error and required no response. The Examiner confirmed he will issue another Office Action in the next two weeks. The Examiner confirmed that the

application is in good standing and no action is required by the Applicant at this time.

No agreement as to the claims was reached.

Further, if there are any additional charges, or any overpayment, in connection herewith, the Commissioner is hereby authorized to charge any such deficiency, or credit any such overpayment, to Deposit Account No. 23-3060. This response is believed to be timely, however, in the event that the Commissioner deems it to be untimely, then please consider this as a petition for extension of time with authorization to charge deposit account 23-3060 therefor.

Respectfully Submitted,

Woodling, Krost and Rust

/Karl V. Kurple/

Karl Kurple
Patent Agent, 57,440
Kenneth L. Mitchell
Patent Attorney, 36,873
Registered Professional Engineer
Woodling, Krost and Rust
9213 Chillicothe Road
Kirtland, Ohio 44094
phone no. 440_256_4150;
fax no. 440_256_7453;

clevepat@sbcglobal.net